## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application

Inventor: Jeffrey W. Carr Appln. No.: 10/608,384

Confirm. No.: 7970 Filed: June 27, 2003

Title: APPARATUS AND METHOD FOR REACTIVE

ATOM PLASMA PROCESSING FOR

MATERIAL DEPOSITION

PATENT APPLICATION

Art Unit: 1765

Vinh, L. Examiner:

Customer No. 23910

### **CERTIFICATE OF MAILING UNDER 37 CFR § 1.8**

I hereby certify that this correspondence is being deposited in the United States Postal Service with sufficient postage as first class mail in an envelope addressed to Art Unit 1711, Commissioner for Patents, Alexandria, VA 22313-1450, on the date shown below.

(Signature)

.a⁄ura Hulac

Signature Date: \_

# REPLY TO OFFICE ACTION UNDER 37 CFR § 1.111

Commissioner for Patents PO Box 1450 Alexandria, VA 22313-1450

Dear Sir:

## INTRODUCTORY COMMENTS

This Reply is in response to the Office Action dated February 1, 2005.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 9 of this paper.